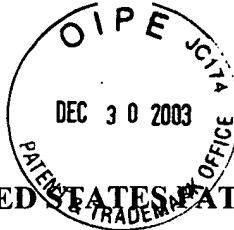


Docket No. YO999-408CIP



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re Application of**

Cohen, et al.

**Serial No.:** 09/902,483

**Group Art Unit:** 2813

**Filed:** July 11, 2001

**Examiner:** Kielin, Erik J.

**For:** SELF-ALIGNED SILICIDE (SALICIDE) PROCESS FOR LOW RESISTIVITY CONTACTS TO THIN FILM SILICON-ON-INSULATOR AND BULK MOSFETS AND FOR SHALLOW JUNCTIONS

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PETITION AND FEE FOR EXTENSION OF TIME  
UNDER 37 C.F.R. 1.136(a)**

Sir:

Applicant hereby petitions for a One-month extension of time to respond to the Office Action mailed September 4, 2003. Please charge Assignee's Deposit Account No. 50-0510 in the amount of \$ 110.00 to cover the statutory amount for a One-month extension fee. A Request for Continued Examination (R.C.E.) is being filed simultaneously herewith. A duplicate copy of this sheet is enclosed.

The Commissioner is authorized charge any deficiencies in fees and credit any overpayment of fees to Assignee's Deposit Account No. 50-0510.

01/02/2004 NDANTE1 00000003 500510 09902483

02 FC:1251 110.00 DA

Date: 12/30/03  
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Respectfully submitted,

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